

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

REQUEST FOR CERTIFICATE OF CORRECTION PURSUANT TO 37 C.F.R. § 1.322		Docket Number: 10191/2235
Application Number 10/049,474	Filing Date July 18, 2002	Examiner TRAN, Minh Loan
Patent Number	Issue Date	

April 6, 2004

Certificate

Conf. No.: 4101

Art Unit 2826

Invention Title

6,716,714

SEMICONDUCTOR DIODE AND METHOD FOR PRODUCING THE SAME

Inventor(s) Herbert GOEBEL et al. DEC 2 2 2004

of Correction

Address to:

Commissioner For Patents P. O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA

We have compared the above patent with the application as filed and have found errors in the printing of the patent. We respectfully request that the enclosed Certificate of Correction on Form PTO-1050 be issued correcting the mistakes set forth therein under authority of 35 U.S.C. §254. The exact column and line number where the errors occur in the patent are listed on the enclosed certificate.

The errors that appear in this patent are Patent Office errors and no fee is believed required. However, if necessary, please charge any fee or credit any overpayment to Deposit Account No. 11-0600.

Dated: /2/13/04

By:

KENYON & KENYON

One Broadway

New York, New York 10004

(212) 425-7200 (telephone)

(212) 425-5288 (facsimile)



U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

REQUEST FOR CERTIFICATE OF CORRECTION PURSUANT TO 37 C.F.R. § 1.322		Docket Number: 10191/2235	Conf. No.: 4101
Application Number 10/049,474	Filing Date July 18, 2002	Examiner TRAN, Minh Loan	Art Unit 2826
Patent Number 6,716,714	April 6, 2004		

Invention Title

SEMICONDUCTOR DIODE AND METHOD FOR PRODUCING THE SAME

Inventor(s)

Herbert GOEBEL et al.

Address to:

Commissioner For Patents P. O. Box 1450 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to : Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date:

We have compared the above patent with the application as filed and have found errors in the printing of the patent. We respectfully request that the enclosed Certificate of Correction on Form PTO-1050 be issued correcting the mistakes set forth therein under authority of 35 U.S.C. §254. The exact column and line number where the errors occur in the patent are listed on the enclosed certificate.

The errors that appear in this patent are Patent Office errors and no fee is believed required. However, if necessary, please charge any fee or credit any overpayment to Deposit Account No. 11-0600.

Dated: /2/13/04

By:

Richard L. Mayer, Reg. No.

KENYON & KENYON

One Broadway

New York, New York 10004

(212) 425-7200 (telephone)

(212) 425-5288 (facsimile)

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT No.:

6,716,714

DATED

April 6, 2004

INVENTOR(S):

Herbert GOEBEL et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the face of the patent, # (57) Abstract, line 8, change "voltage of diode." to – voltage of the diode--

Column 1, line 33, change "the silicon" to --the silicon chip, the allowable current load to be increased and the thermal loading of the silicon chip to be reduced in a manner that can be realized relatively simply. In so doing, a reduction in the forward voltage is simultaneously achieved. The effect of additional saw grooves is particularly advantageous, because later, when the socket and lead wire are soldered to the diode chip, the grooves lead to a better, bubble-free soldering procedure (capillary effect), and the grooves filled with solder result in additional, more effective cooling of the chip, which extends into the depth of the silicon body and therefore thermally couples the chip to the heat sink in a more effective manner.

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1a shows a cross-sectional side view of a diode in accordance with the present invention.

Fig. 1b shows a plan view of the diode shown in Fig. 1a.

Fig. 2 shows a semiconductor wafer used as the starting material in a method for producing the semiconductor arrangement in accordance with the present invention.

Fig. 3 shows the semiconductor wafer in a further method step for producing the semiconductor arrangement in accordance with the present invention.

Fig. 4 shows the semiconductor wafer in yet another method step for producing the semiconductor arrangement in accordance with the present invention.--

Column 2, line 43, change "neutral is filing" to --neutral filing--

MAILING ADDRESS OF SENDER

Patent No. 6,716,714 B1

No. of add'l. copies

One Broadway

Kenyon & Kenyon

New York, NY 10004

@ 30 ¢ per page ⇒

FORM PTO 1050 (REV 3.82) MODIFIED